

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Freese et al.	Confirmation No.: 8346
Serial No.: 10/661,917	Examiner: Daborah Chacko Davis
Filed: September 11, 2003	Group Art Unit: 1795
For: METHODS FOR MASTERING MICROSTRUCTURES THROUGH A SUBSTRATE USING NEGATIVE PHOTORESIST	

September 13, 2010

Mail Stop Issue Fee  
Commissioner for Patents  
Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT AFTER ALLOWANCE PURSUANT TO 37 CFR 1.312**

Sir:

The present Amendment is being filed in response to the Notice of Allowance mailed September 7, 2010.

If any extension of time for the accompanying response or submission is required, please consider this a petition therefor. The Commissioner is hereby authorized to charge any additional fee, which may be required, or credit any refund, to our Deposit Account No. 50-0220.

**Amendments** to the title begin on Page 2 of this paper.

**Remarks** begin on Page 3 of this paper.